

TECHNICAL  
REPORT

ISO/TR  
18196

First edition  
2016-11-15

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**Nanotechnologies — Measurement  
technique matrix for the  
characterization of nano-objects**

*Nanotechnologies — Matrice de méthodes de mesure pour les nano-  
objets manufacturés*



Reference number  
ISO/TR 18196:2016(E)

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## Foreword

ISO (the International Organization for Standardization) is a worldwide federation of national standards bodies (ISO member bodies). The work of preparing International Standards is normally carried out through ISO technical committees. Each member body interested in a subject for which a technical committee has been established has the right to be represented on that committee. International organizations, governmental and non-governmental, in liaison with ISO, also take part in the work. ISO collaborates closely with the International Electrotechnical Commission (IEC) on all matters of electrotechnical standardization.

The procedures used to develop this document and those intended for its further maintenance are described in the ISO/IEC Directives, Part 1. In particular the different approval criteria needed for the different types of ISO documents should be noted. This document was drafted in accordance with the editorial rules of the ISO/IEC Directives, Part 2 (see [www.iso.org/directives](http://www.iso.org/directives)).

Attention is drawn to the possibility that some of the elements of this document may be the subject of patent rights. ISO shall not be held responsible for identifying any or all such patent rights. Details of any patent rights identified during the development of the document will be in the Introduction and/or on the ISO list of patent declarations received (see [www.iso.org/patents](http://www.iso.org/patents)).

Any trade name used in this document is information given for the convenience of users and does not constitute an endorsement.

For an explanation on the meaning of ISO specific terms and expressions related to conformity assessment, as well as information about ISO's adherence to the World Trade Organization (WTO) principles in the Technical Barriers to Trade (TBT) see the following URL: [www.iso.org/iso/foreword.html](http://www.iso.org/iso/foreword.html).

The committee responsible for this document is ISO/TC 229, *Nanotechnologies*.

## Introduction

This document connects the nano-object parameters that most commonly need to be measured with corresponding measurement techniques. This document will be a useful tool for nanotechnology interested parties to rapidly identify relevant information for measuring nano-objects. The common nano-object parameters are listed along the top row of the Quick-Use-Matrix (see [Table 1](#)). If a measurement technique listed in the first column of the matrix is applicable, the box in the matrix will be marked. Once a measurement technique of interest is identified, it is recommended that the reader then enter this document's body of text (see [Clause 5](#)), where you will find an alphabetical listing of the measurement techniques and descriptions of the advantages, limitations, relevant standards, measurand(s), and applicable nano-object parameters of each technique.

As scientific advances are made and additional commercial measurement techniques become available, this document will be periodically reviewed and updated to maintain its relevance.

Many of the techniques listed in this document have not been validated through round-robin testing or any other means for the measurement of nano-objects. This document is intended as a starting point and resource to help identify potentially useful and relevant techniques; it is not an exhaustive or primary source. It is recommended that once a technique has been identified, the reader refers to relevant international standards and conducts a literature search for similar or comparable applications. Other sources of information include instrument manufacturer's applications notes and technical literature.



# Nanotechnologies — Measurement technique matrix for the characterization of nano-objects

## 1 Scope

This document provides a matrix that guides users to commercially available techniques relevant to the measurements of common physicochemical parameters for nano-objects. Some techniques are also applicable to nanostructured materials.

NOTE Guidance on sample separation and preparation is given in [Annex A](#).

## 2 Normative references

There are no normative references in this document.

## 3 Terms and definitions

For the purposes of this document, the terms and definitions given in ISO/TS 80004-1, ISO/TS 80004-6 and the following apply.

ISO and IEC maintain terminological databases for use in standardization at the following addresses:

- IEC Electropedia: available at <http://www.electropedia.org/>
- ISO Online browsing platform: available at <http://www.iso.org/obp>

### 3.1 General terms

#### 3.1.1

#### dispersion

heterogeneous system in which a finely divided material is distributed in another material

[SOURCE: ISO 472:2013, 2.288]

#### 3.1.2

#### measurand

quantity intended to be measured

[SOURCE: ISO Guide 99:2007, 2.3]

#### 3.1.3

#### nano-object

discrete piece of material with one, two or three external dimensions in the nanoscale

Note 1 to entry: The second and third external dimensions are orthogonal to the first dimension and to each other.

[SOURCE: ISO/TS 80004-2:2015, 2.2]

#### 3.1.4

#### nanostructured material

material having internal or surface structure in the nanoscale

Note 1 to entry: If external dimensions are in the nanoscale, the term *nano-object* ([3.1.3](#)) is recommended.

[SOURCE: ISO/TS 80004-4:2011, 2.11]